

# PATENT ABSTRACTS OF JAPAN

(11)Publication number : 2003-075024

(43)Date of publication of application : 12.03.2003

(51)Int.Cl.

F25B 39/02  
B21D 53/08  
B60H 1/32  
F25B 1/00  
F28D 9/02  
F28F 9/02  
F28F 9/18  
F28F 9/22

(21)Application number : 2002-165553

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(22)Date of filing : 06.06.2002

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(30)Priority

Priority number : 2001183062

Priority date : 18.06.2001

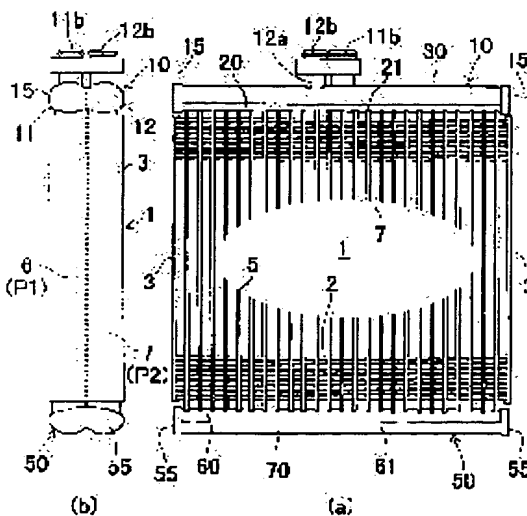
Priority country : JP

## (54) EVAPORATOR, ITS MANUFACTURING METHOD, HEADER MEMBER FOR THE VAPORIZER AND REFRIGERATING SYSTEM

### (57)Abstract:

**PROBLEM TO BE SOLVED:** To provide an evaporator to improve heat exchanger performance and be capable of reducing thickness.

**SOLUTION:** An evaporator is provided with a core 1 at which heat exchange tube groups P1 and P2 on the upper stream side and the downstream side are longitudinally juxtaposed, and upper side and lower side header members 10 and 50 situated at the upper and lower ends of the core 1. The interior of the upper side header member is longitudinally partitioned to form tanks 11 and 12 on the inlet side and the outlet side. One end of each tube 6 of a tube group P1 on the upper stream side is coupled to a tank 11 on the inlet side, and the other end is coupled to the header member 50 on the lower side. One end of each tube 7 of each tube group 7 of a tube group P2 on the downstream side is coupled to the header member 50 on the lower side. A refrigerant flowing in the tank 11 on the inlet side flows through the tube group P1 on the upper stream side and is introduced to the tank 12 on the outlet side. Meanwhile, a refrigerant flowing through the two heat exchange tube groups P1 and P2 is heat-exchanged with outside air A and evaporated.



### LEGAL STATUS

[Date of request for examination]

06.04.2005

[Date of sending the examiner's decision of

rejection]

[Kind of final disposal of application other than  
the examiner's decision of rejection or  
application converted registration]

[Date of final disposal for application]

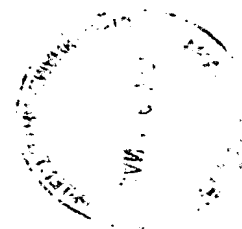
[Patent number]

[Date of registration]

[Number of appeal against examiner's decision  
of rejection]

[Date of requesting appeal against examiner's  
decision of rejection]

[Date of extinction of right]



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